



09/909580

Certificate

JAN 18 2007

of Correction

PATENT

CFC

I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

12-6-06

Date

Jennifer A. Steele

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Nathan R. Brown

Attorney Docket No.: 500200.04

Patent No. : US 6,872,131 B2

Issued : March 29, 2005

Title : METHOD AND APPARATUS FOR CHEMICAL-MECHANICAL PLANARIZATION
OF MICROELECTRONIC SUBSTRATES WITH A CARRIER AND MEMBRANE**NOTIFICATION OF ERRORS**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

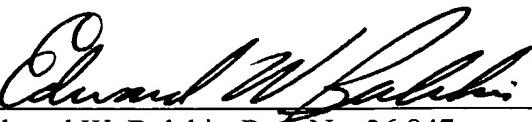
The following errors were noted in a review of the above-identified letters patent. One of these errors was inadvertently made in the original application, while the others occurred in the printing of the patent. Since the errors are of an obvious nature, a formal Certificate of Correction is not believed to be warranted at this time. Therefore, applicant requests that this notification be placed in the Patent and Trademark Office file.

<u>Column, Line</u>	<u>Reads</u>	<u>Should Read</u>
Column 3, Line 10	"because of the flow of gas"	--because the flow of gas--
Column 5, Line 59	"the frictional at forces"	--the frictional forces--

Respectfully submitted,

Date: Dec. 4, 2006

By:



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Enclosure:
Postcard

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